

# Undulators and bending magnet sources at the ALS-U

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## Acknowledgments and references

- ▶ The material is presented on behalf of the groups working with ALS and ALS-U at Lawrence Berkeley National Laboratory.
- ▶ Material has been copied from the ALS-U CDR with contributions from, for example, A. MacDowell, S. Morton, H. Padmore, D. Robin, F. Sannibale, C. Steier, C. Sun, C. Swenson, M. Venturin, S. Leemann, and W. Waldron.
- ▶ The software Radia has been used for magnet models of insertion devices [O. Chubar, P. Elleaume and J. Chavanne, "A 3d magnetostatics computer code for insertion devices," *Journal of Synchrotron Radiation*, 5:481-484, 1998.].
- ▶ The software Spectra has been used for calculation of synchrotron radiation [T. Tanaka and H. Kitamura, *Journal of Synchrotron Radiation* 8, 1221 (2001).].
- ▶ The software SRW has been used for calculation of synchrotron radiation [O. Chubar and P. Elleaume, *Proceedings of EPAC 1998* , 1177 (1998).].

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## FACILITY FACTS

22

Years in  
operation

~200

Total ALS  
staff

&gt;800

Referred  
publications  
per year

\$60M

Average  
operating  
budget per year

5000

Average number  
of operating  
hours per year

40

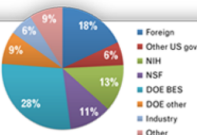
Number of  
beamlines

## USER STATS

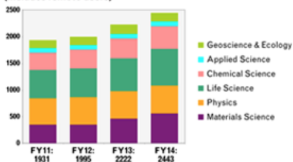
50-100

Users on site at  
any one time1 hour to  
10 daysAverage stay of  
users

### Users by Funding



### Users per Discipline per Fiscal Year (includes remote users)

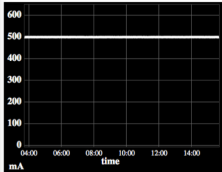


**User Operations Shift: Top-off Mode**  
1.9 GeV, 296 buckets, 500 mA, single cam  
User Beam ends: Monday, December 04 at 8 AM

500.7 mA

Fri Dec 01

3:42:35 PM

LIGHT  
AVAILABLE

GeV	1.9	Life(Hr)	6.3
ID GAP (mm)	20.10	702	33.63
4U1	24.88	722	-0.00
4U2	35.26	80	26.52
4X2	0.00	90	29.59
5W	13.70	100	55.78
6U1	35.70	1101	26.93
6U2	201.13	1121	-0.00
6X2	0.59	1102	22.48
7U1	16.01	1122	17.24
7X1	-0.00	120	54.00
XRM1	45.20	YRM1	46.60

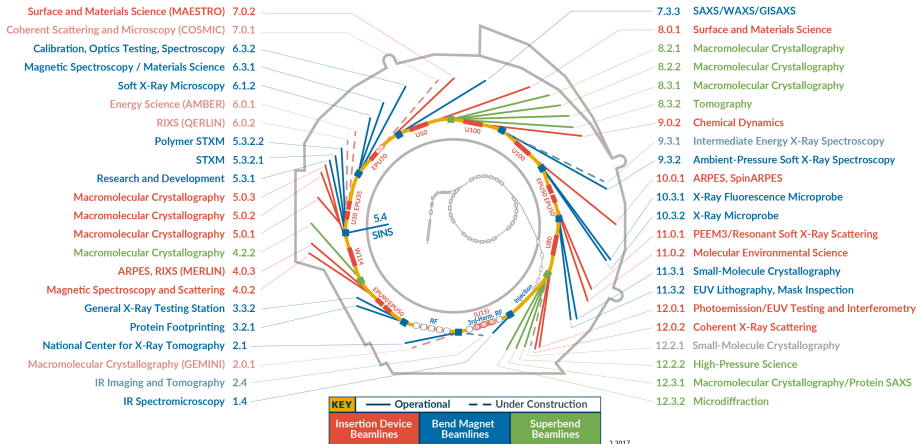
Beam lost at: Nov 29 21:49

due to:



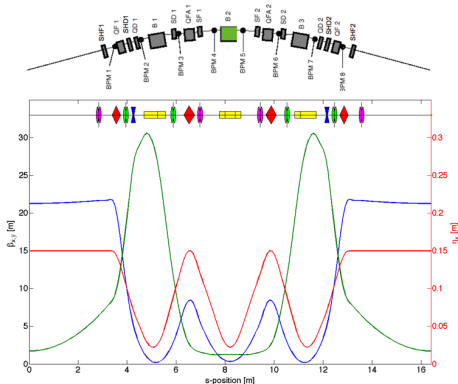
## ALS has 28 bend magnet end stations and 22 insertin device end stations

## ALS Beamlines

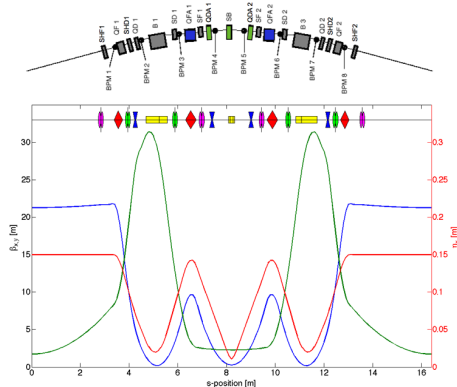


# The 3 superbends (6 T superconducting dipole) is a unique feature of the ALS

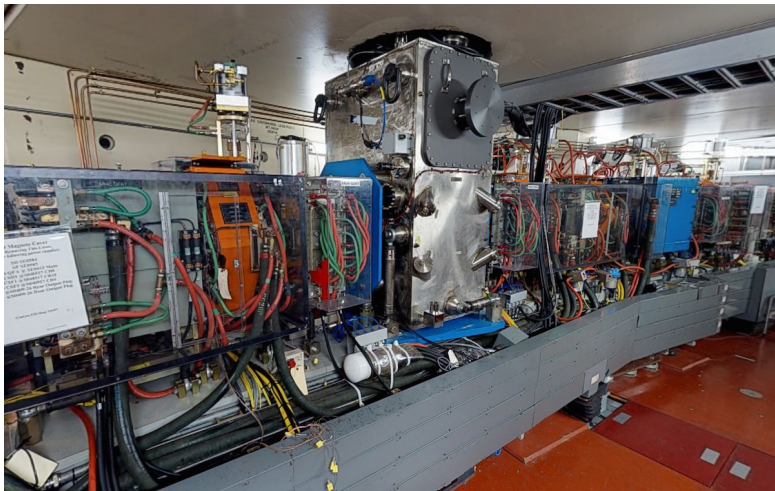
## Normal ALS Sector



## Modified Superbend ALS Sector



## ALS sector with superbend



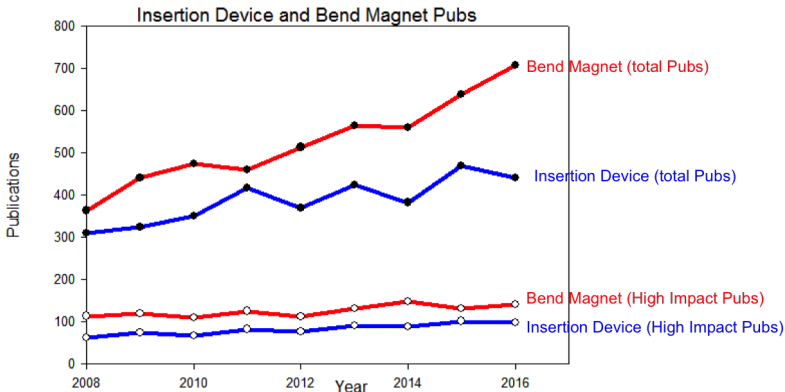
## ALS insertion devices, 14 IDs, 17 beamlines, 22 end stations

Device	BL	P. L. [mm]	No. of Periods	ID Gap [mm]	ID Eff. Field [T]	ID Ph.En. [eV]
U15	2.0.1	15	131	4.3-20	1.05-0.15	7000-15000 <sup>a</sup>
EPU50	4.0.2	50	37	14-55	0.80-0.10 <sup>v</sup> 0.58-0.10 <sup>h</sup>	73-3000
QEPU90	4.0.3	90	20.5	14.5-99	1.18-0.06 <sup>v</sup> 0.78-0.06 <sup>h</sup>	8-1600
W114	5.0.1 5.0.2 5.0.3	114	29	12.5-180	1.94-0.03	6-21000
U30 U30-w	6.0.1	30	50	5.5-27	1.5-0.13	120-5000 4-11 keV
EPU35	6.0.2	35	52.5	12-40	0.71-0.06	265-4000
EPU38	7.0.1	38	44.5	12.5-75	0.89-0.11 <sup>v</sup> 0.67-0.11 <sup>h</sup>	150-2500
EPU70	7.0.2	70	26.5	12.5-75	1.18-0.07	16-2000
U50	8.0.1	50	89	14-45	0.85-0.10	80-3000
U100	9.0.1	100	43	22.7-116	0.98-0.05	8-1500
U100	10.0.1	100	43	23.1-116	0.80-0.05	12-1500
EPU50	11.0.1	50	36.5	14.3-55	0.85-0.10 <sup>v</sup>	75-3000 0.57-0.10 <sup>h</sup>
EPU50	11.0.2	50	37	13.8-55	0.86-0.10 <sup>v</sup> 0.58-0.10 <sup>h</sup>	71-3000
U80	12.0.1 12.0.2	80	55	24.7-83	0.80-0.07	20-1900

<sup>a</sup> Harmonic 5-11    <sup>b</sup> Harmonic 11    <sup>v</sup> Vertical Field    <sup>h</sup> Horizontal Field

# ALS publications from insertion device straights and bend magnet beamlines

-60% ALS publications from Bend Magnet beamlines (including Super bends @ 24%)



Bend End stations (**28**) 14, 21, 321, 332, 422, 531, 5321, 5322, 54, 612, 6311, 6312, 632, 731, 733, 821, 822, 831, 832, 931, 932, 1031, 1032, 1131, 1132, 1222, 1231, 1232  
 ID End stations (**22**) 402, 4031, 4032, 501, 502, 503, 601, 602, 7011, 7012, 801, 901, 902, 10011, 10012, 11011, 11012, 11021, 11021, 12011, 12012, 1202

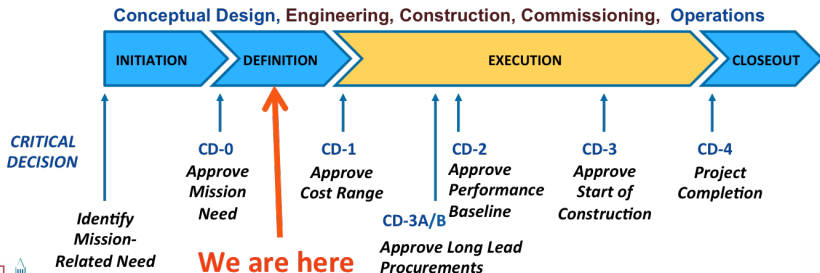


## High-level performance goals of the upgrade of ALS

- ▶ Achieve an increase in the brightness and coherent flux for soft x-rays at 1 keV photon energy of at least two orders of magnitude beyond today's ALS capabilities
- ▶ Develop a set of experimental capabilities that will enable leadership in soft x-ray science
- ▶ Provide infrared capability that extends across the wavelength range provided at present day ALS
- ▶ Provide hard x-ray capability comparable to present-day ALS

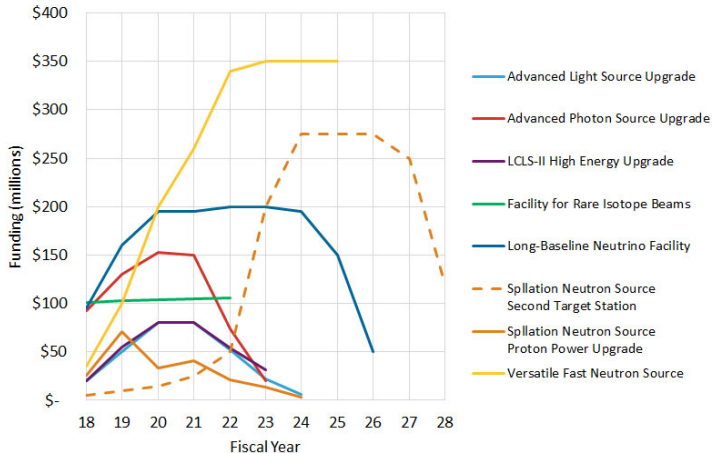
## Stages of a DOE project – ALS-U is working towards CD-1

- ▶ Finished first (partial) CDR draft in May 2017
- ▶ First ESAC+MAC meetings in early summer 2017
- ▶ Currently working on system integration and second CDR draft
- ▶ Completed first technical design review (Dipole B, R+D magnet) planning round of technical conceptual design reviews for spring



## Funding situation as proposed in a bill from the House of Representatives (dynamic)

## Proposed DOE Facility Funding Authorizations

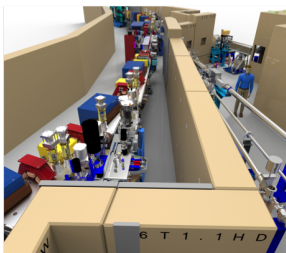




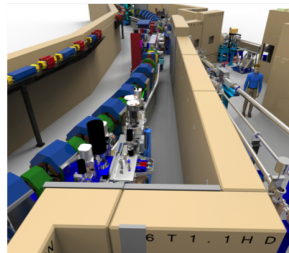
## Scope of ALS-U

1. **Replacement** of the existing triple-bend achromat storage ring with a new, high-performance storage ring based on a **multi-bend achromat**.
2. **Addition** of a low-emittance, full-energy **accumulator ring** in the existing storage-ring tunnel to enable on-axis, **swap-out injection** using fast magnets.
3. **Upgrade** of the optics on existing beamlines and realignment or relocation of beamlines where necessary.
4. **Addition** of three new undulator beamlines that are optimized for novel science made possible by the beam's high coherent flux.

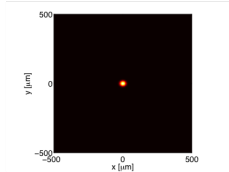
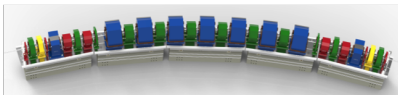
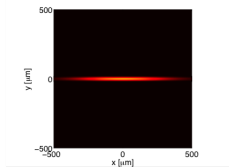
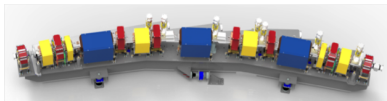
Existing ALS ring



New accumulator ring    New ALS-U ring



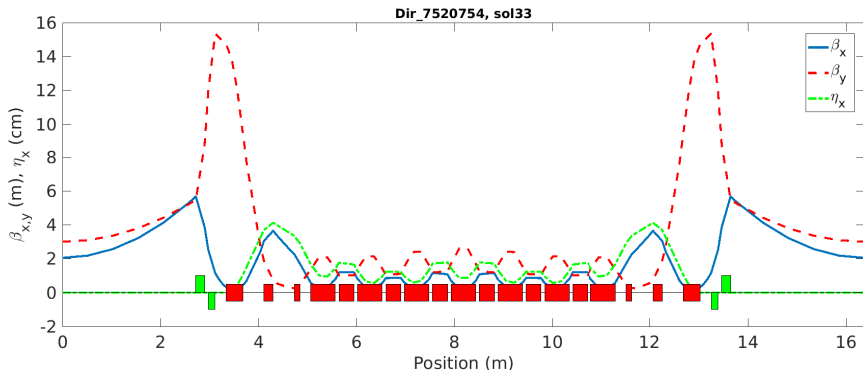
## ALS and ALS-U in numbers



Parameter	Units	ALS	ALS-U
Electron energy	GeV	1.9	2.0
Horiz. emittance	pm	2000	<70
Vert. emittance	pm	30	<70
Beamsize @ ID center ( $\sigma_x/\sigma_y$ )	mm	251 / 9	<13 / <13
Beamsize @ bend ( $\sigma_x/\sigma_y$ )	mm	40 / 7	<7 / <10
bunch length (FWHM)	ps	60-70 (harmonic cavity)	100-200 (harmonic cavity)
RF frequency	MHz	500	500
Circumference	m	196.8	~196.5

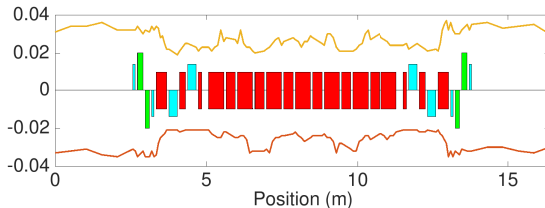
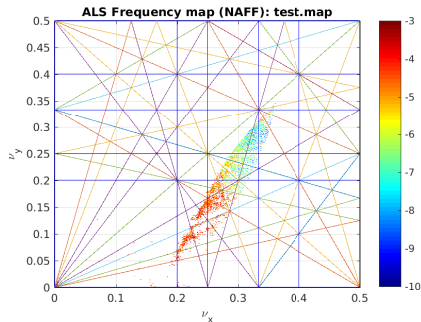
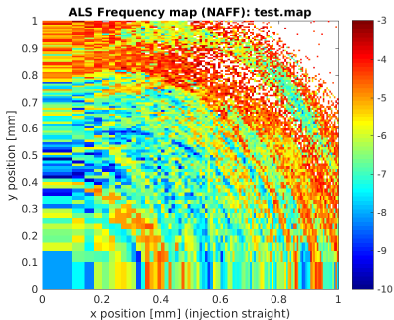


# Multibend achromat with 9 bend magnets with reverse bends from QF with offset



Twiss functions for lattice v20r. The lattice has 12 fold symmetry.

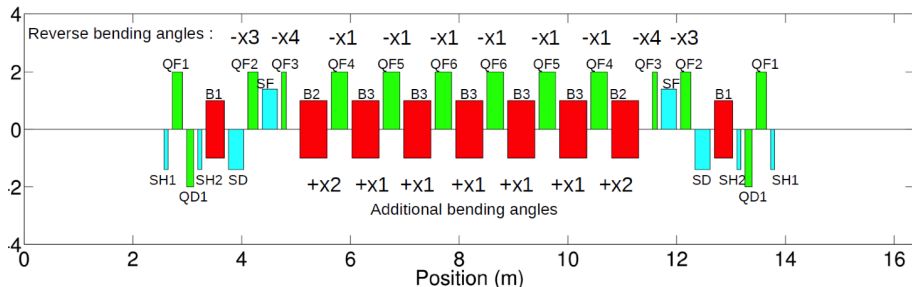
## Lattice v20r frequency-map, tune footprint, and momentum aperture (with errors)



## Storage ring parameters for lattice v20r

Lattice parameters		RF and related parameters	
Lattice type	9BA(w/ rev. bend)	Electron energy, $E$	2.0 GeV
Lattice version	v20r	Harmonic number, $h$	328
Tunes, $\nu_x/\nu_y$	41.357/20.354	Main rf cavity resonance frequency,	500 MHz
Natural chromaticities, $\xi_{0x}/\xi_{0y}$	-65.2/64.84	Main rf cavity voltage (HC tuned out),	0.60 MV
Chromaticities during operation, $\xi_x/\xi_y$	1/1	RF Harmonic cavity frequency,	1,500 MHz
Beta functions at IDs, $\beta_x/\beta_y$	$\sim 2/3$ m	RF Harmonic cavity voltage,	0.17 MV
Dispersion functions at IDs, $\eta_x/\eta_y$	<1/1 mm	Natural rms bunch length (no HC), $\sigma_{r0}/\sigma_{z0}$	11.8 ps (3.55 mm)
Circumference, $C$	196.5 m	Bunch length (FWHM, with HC)	112 ps (33.4 mm)
Revolution time, $T_0$	0.655 $\mu$ s	RF relative momentum acceptance, $\delta_{RF}$	3.7%
Momentum compaction, $\alpha_c$	$2.11 \times 10^{-4}$	Synchrotron-oscillation tune, $\nu_s$	$1.75 \times 10^{-3}$
<b>Radiation and related parameters</b>		Synchrotron-oscillation frequency, $f_s$	2.68 kHz
Natural rms emittance, $\epsilon_{0x}$	92 pm	<b>Other parameters</b>	
Rms emittances w/ full coupling, $\epsilon_x = \epsilon_y$	62 pm	Total no. of bunches	284
Rms natural relative energy spread, $\sigma_\delta$	$9.43 \times 10^{-4}$	Total no. of trains	11
Radiation energy loss per turn from dipoles, $U_D$	217 keV	Min. separation between bunches	2 ns
Radiation energy loss per turn from IDs, $U_{ID}$	<70 keV	Min. separation between trains	10 ns
Total energy loss per turn, $U_0$	<287 keV	Average current, $I_{avg}$	500 mA
Partition numbers, $J_x/J_y/J_z$	2.08/1/0.91	Single-bunch current, $I_b$	1.76 mA
Damping times (dipole radiation), $\tau_x/\tau_y/\tau_z$	5.8/12.1/13.8 ms	Touschek lifetime, $\tau_s$	$\approx 1$ h

## Reverse bend configuration



- Reverse bending is achieved by offset quadrupoles QF2(-x3), QF3(-x4), QF4-QF6(-x1)
- Additional bending in the magnet B2(+x2) and B3(+x1) to set overall bending angle to 30 deg per sector
- 3 knobs for reverse bending angles: x1, x2, x3,  $x4 = x2 - x1/2 - x3$

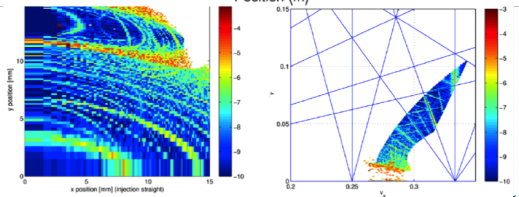
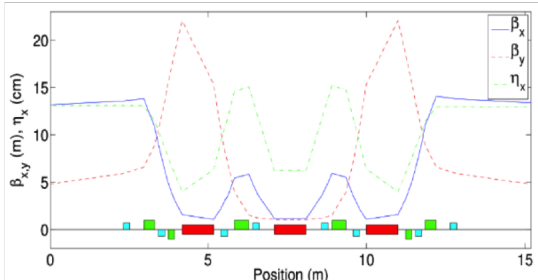
## Reverse bend magnet parameters

Storage-ring v20r lattice specifications for the magnet effective length ( $L$ ), bending angle ( $\theta$ ), bending field  $B_0$ , quadrupole and sextupole unnormalized ( $B'$ ,  $B''$ ) and normalized ( $K_1$ ,  $K_2$ , MAD convention) gradient-field components. All magnets have two counts in each of the 12 sectors, except for B3 (five counts per sector.) Negative signs for the bending angle and  $B$ -field denote reverse bending.

Name	$L$ (m)	$\theta$ (deg)	$B_0$ (T)	$K_1$ (m <sup>-1</sup> )	$B'$ (T/m)	$K_2$ (m <sup>-2</sup> )	$B''$ (T/m <sup>2</sup> )
B1	0.34	3.333	1.141	-3.000	-20.000	-	-
B2	0.5	3.646	0.848	-7.057	-47.050	-	-
B3	0.5	3.763	0.848	-7.057	-47.050	-	-
QF1	0.18	-	-	13.768	91.785	-	-
QF2	0.19	-0.0914	-0.056	10.224	68.160	-	-
QF3	0.115	-0.0062	-0.006	10.546	70.307	-	-
QF4	0.305	-0.429	-0.164	15.282	101.884	-	-
QF5	0.305	-0.429	-0.164	15.795	105.305	-	-
QF6	0.305	-0.429	-0.164	15.761	105.075	-	-
QD1	0.14	-	-	-13.432	-89.545	-	-
SF	0.28	-	-	-	-	1562.9	10,419
SD	0.28	-	-	-	-	-1280.4	8,535
SHF	0.075	-	-	-	-	77.72	518.1
SHD	0.075	-	-	-	-	-1156.4	7,709

# Accumulator ring with triple bend achromat lattice

Accumulator Ring	
<b>Lattice parameters</b>	
Lattice type	TBA
Tune, $\nu_x/\nu_y$	15.345/8.106
Natural chromaticity, $\xi_{0x}/\xi_{0y}$	-34.9/-30.4
Chromaticity during operation, $\xi_x/\xi_y$	1/1
Circumference, $C$	182.122 m
Revolution time, $T_0$	0.607 $\mu$ s
Revolution frequency, $f_0$	1.64 MHz
Momentum compaction, $\alpha_c$	$1.31 \times 10^{-3}$
<b>Radiation and related parameters</b>	
Natural rms emittance, $\epsilon_{x0}$	2 nm
Rms natural energy spread, $\sigma_\delta$	$0.8 \times 10^{-3}$
Radiation energy loss per turn, $U_0$	247 keV
Partition numbers, $J_x/J_y/J_z$	1.42/1/1.57
Damping times (dipole radiation), $\tau_x/\tau_y/\tau_z$	6.92/9.83/6.22
<b>RF and related parameters</b>	
Electron energy, $E$	2.0 GeV
Harmonic number, $h$	304
Main rf cavity frequency, $f_{r1}$	500 MHz
Main rf cavity voltage, $V_1$	1.3 MV
Rms natural bunch length $\sigma_z$	4.8 mm
RF relative momentum acceptance, $\delta_{RF}$	$2.7 \times 10^{-2}$
Synchrotron oscillations tune, $\nu_s$	$6.37 \times 10^{-3}$
Synchrotron oscillations frequency, $f_s$	10.49 kHz
<b>Other parameters</b>	
Touschek lifetime, $\tau_T$	N/A $\approx$ h
Gas scattering lifetime,	N/A



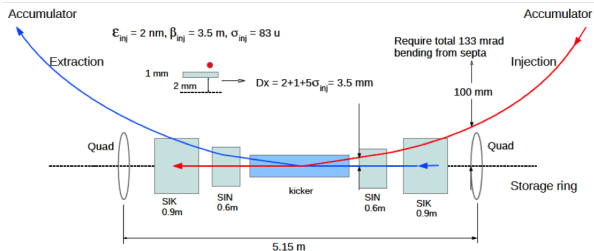


## ALS-U Technical challenges

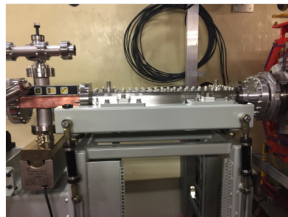
- ▶ Emittance increase due to intrabeam scattering
- ▶ Swap-out injection
- ▶ Tightly packed MBA lattice
- ▶ Very high magnet packing density
- ▶ Alignment of the magnets
- ▶ Small ( 20 mm) aperture NEG-coated vacuum chambers for the acclerator sectors
- ▶ Vacuum system to allow all dipole and straight section light ports
- ▶ Very small (4 to 6 mm) aperture NEG-coated vacuum chambers for the straight sections

## Accelerator R&amp;D: Swap-out injection technology demonstrated on ALS

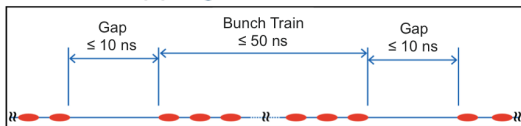
## Injection swap-out concept



## Fast kicker installed

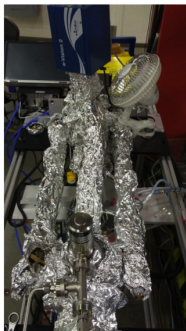


## Swapping out a bunch train

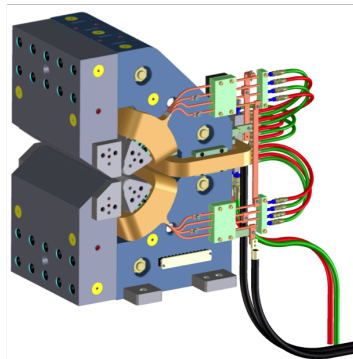


## Accelerator R&D: Vacuum and magnets

Successfully activated  
first LBNL-coated small-  
gap (6 and 9 mm) NEG  
vacuum chambers



Completed design of R&D  
storage ring lattice magnet



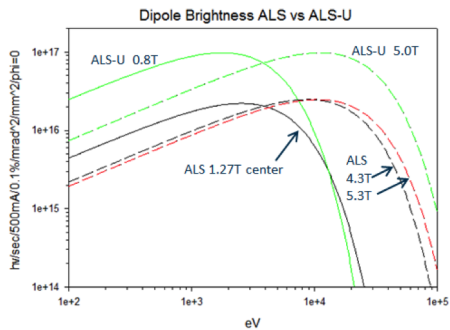
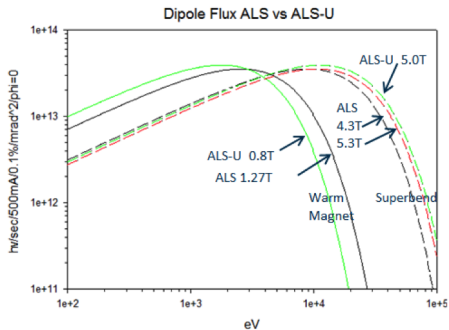
ALS-U Bending Magnets

# Scope of bend magnet beamline move suggests about 25 beamlines to move

Beamline	Name	Technique	Existing source	Angle from Straight Deg	Angle from Straight mrad	delta from nominal mrad	eV		Publications	
							min	max		
1	1.4 IR	IR	bend	22.60	394.44	0.00	0.05	1.2	7(0)	
2	2.1 NCXT	Bio Tomography	bend	6.30	109.96	0.00	400	1300	5(1)	
3	2.4 new IR	IR	Commissioning	22.60	394.44	0.00	0.05	1.2	0	
4	3.1 Ring Diagnostics		bend	6.30	109.96	0.00	500	2000	0	
5	3.2.1 LIGA	lithography	bend	11.97	208.91	-11.00	3000	20000	2(0)	
6	3.2.2 Undeveloped	thro the wall	undeveloped	Bend	13.23	230.91	11.00		0	
7	3.3.1 Footprinting	Footprinting	Commissioning	bend	16.77	292.69	-11.00	3000	20000	0
8	3.3.2 Brookhaven detector	Detector development	bend	18.03	314.69	11.00	5000	20000	4(1)	
9	4.2.1 Undeveloped	thro the wall	undeveloped	superbend 2	11.97	208.87	-11.04		0	
10	4.2.2 MBC	MAD MX	superbend 2	13.23	230.85	10.94	5500	16000	38(5)	
11	5.3.1 R&D	Tender X-ray	bend	16.74	292.19	-11.50	1000	13000	11(0)	
12	5.3.2.1 High Energy STXM	Ptychography	bend	18.03	314.69	11.00	600	2000	7(2)	
13	5.3.2.2 Low energy STXM		bend	18.03	314.69	11.00	250	800	37(6)	
14	5.4 BSISB	IR	bend	22.60	394.44	0.00	0.07	1.25	12(2)	
15	6.1.2 XM-1	Microscopy (MSD/CXRO)	bend	6.95	121.30	11.34	500	1300	4(2)	
16	6.3.1 Magnetic/PIPO	Spectroscopy	bend	16.82	293.58	-10.11	250	2000	28(5)	
17	6.3.2 EUV Calibration	Reflectometry	bend	18.07	315.47	11.78	25	1300	8(2)	
18	7.3.1 Soft X-ray	Spectroscopy	Commissioning	bend	16.92	295.39	-8.30	180	1500	0
19	7.3.3 SAXS/WAXS		bend	17.41	303.79	0.10	8000	11000	152(29)	
20	8.2.1 HHMI	MAD MX	superbend 2	11.97	208.86	-11.05	5500	16000	42(9)	
21	8.2.2 HHMI	MAD MX	superbend 2	13.23	230.86	10.95	5500	16000	19(8)	
22	8.3.1 UCB-UCSF	MAD MX	superbend 3	16.77	292.69	-11.00	5500	16000	30(13)	
23	8.3.2 Tomography	Tomography	superbend 3	18.03	314.69	11.00	5000	70000	37(3)	
24	9.3.1 Chem. Materials	Spectroscopy	bend	16.94	295.66	-8.03	30	850	25(5)	
25	9.3.2 Materials	Spectroscopy	bend	17.48	305.16	1.47	2320	5600	8(1)	
26	10.3.1 Microprobe		bend	16.71	291.57	-12.11	3000	20000	5(0)	
27	10.3.2 micro-EXAFS		bend	18.10	315.97	12.28	2400	17000	18(6)	
28	11.3.1 Small-Molec. XTAL	Crystallography	Moving to 1221	bend	16.77	292.69	-11.00	6000	17000	92(17)
29	11.3.2 SHARP	EUV Inspection	bend	18.03	314.68	11.00	50	1000	9(0)	
30	12.2.1 Small-Molec. XTAL	Crystallography	Commissioning	superbend 2	11.97	208.86	-11.05	6000	25000	0
31	12.2.2 High Pressure	Crystallography	superbend 2	13.23	230.86	10.95	6000	40000	30(6)	
32	12.3.1 SIBYLS (PBD/LSD)	MAD MX	superbend 3	16.70	291.44	-12.25	5000	17000	44(11)	
33	12.3.2 Microdiffraction	Crystallography	superbend 3	18.03	314.69	11.00	6000	22000	33(7)	

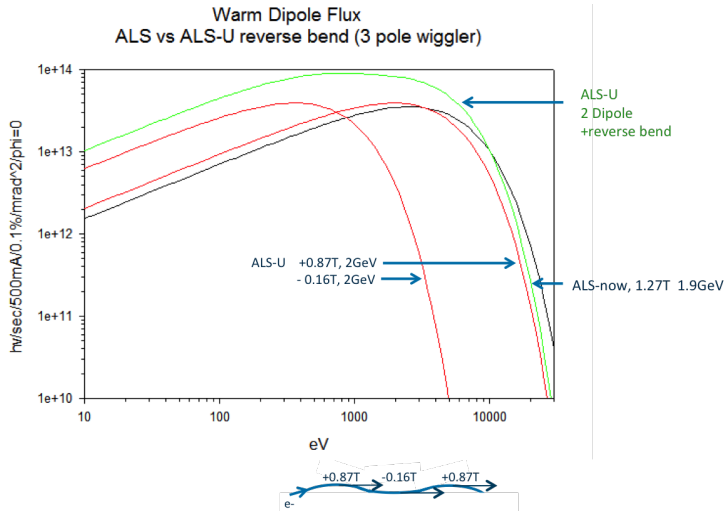


## ALS-U bend magnet performance

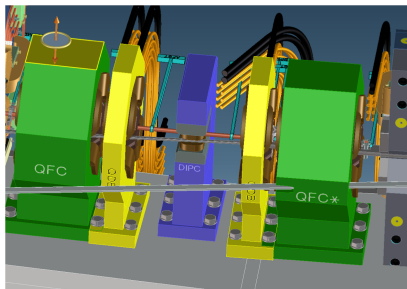
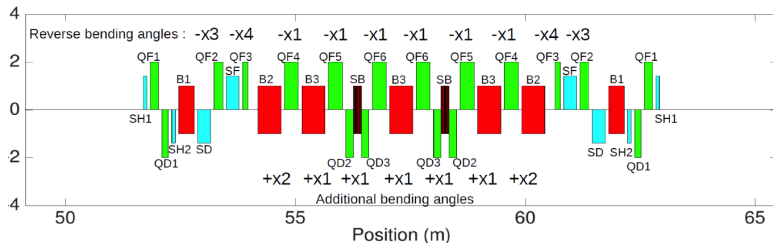


Beam port	Magnet	Source size $\mu\text{m}$ FWHM HxV	
		ALS (2017)	ALS-U
BL x.1	Warm	76x76	20x20
BL x.3	Warm	94x17	20x20
BL x.2	Superbend	62x23	20x20
BL x.3	Superbend	62x23	20x20

## ALS-U reverse bend source – More Flux

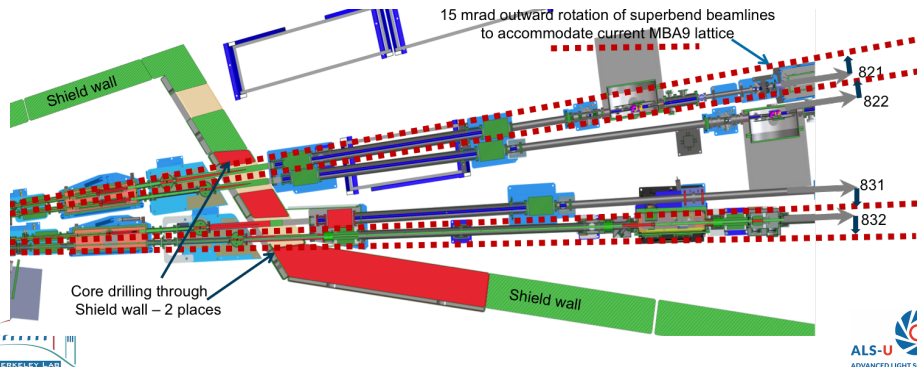


## Initial modeling for installing 3 superbends with 6 beamlines has started



## There is a 15mrad shifts on BL8 superbends

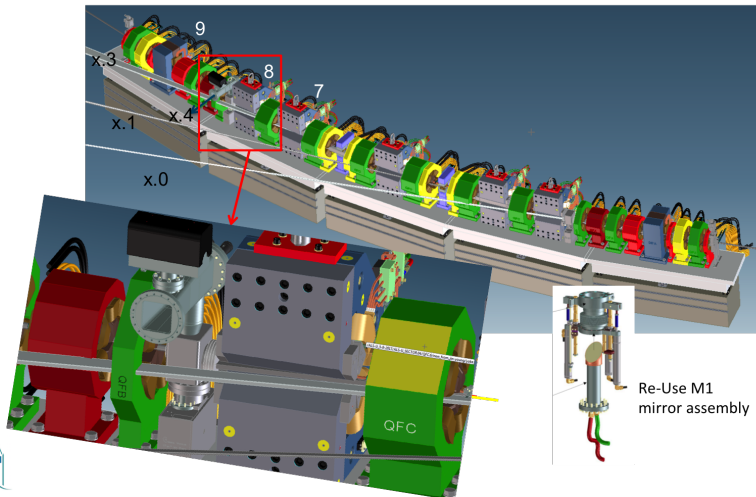
- ▶ Will require core drilling the shield wall at 2 places
- ▶ Translate 4 hutches 375mm to side - expensive
- ▶ All superbend beamlines are productive





## Infra-Red Beamlines 1.4, 2.4, 5.4

- IR beamlines require large opening angle , Currently 69x17 mrad (hvx)
- Location space for M1 between MBA magnets 8 & 9 using light from #7
- Modify optics in ring tunnel to steer beam from a new source point but through same shield hole.



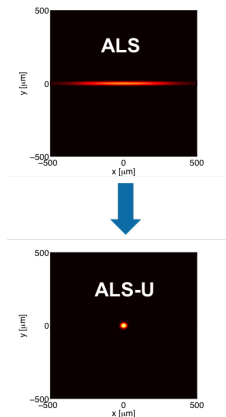
## Defining the detailed plan for moving of the bend magnet BLs is work in progress

- ▶ The bend magnet beamlines are highly productive and cannot be left out from the ALS-U
- ▶ Matching the dipole source points between ALS-U and ALS is not trivial
- ▶ It may be possible to use the reverse bend to increase the flux at warm magnet bend magnet BLs
- ▶ Modeling the superbend lattice and the superbend magnets has started and is work in progress

## Undulators for the ALS-U

- ▶ The small dimensions of the ALS-U beam allows the installation of circular vacuum chambers with down to 4 mm vacuum stay clear diameter
- ▶ The small vacuum chamber gives freedom to choose undulator type and period length.
- ▶ Polarization control is needed for several of the new undulators, which gives EPU, Delta type, X-type, or superconducting undulators.
- ▶ The circular vacuum chamber can be used on complete straight section and the first section of a canted straight section

### Beam Profile Comparison



Interesting development is taking place at SR and FEL sources. Two examples:

## X-Type undulator

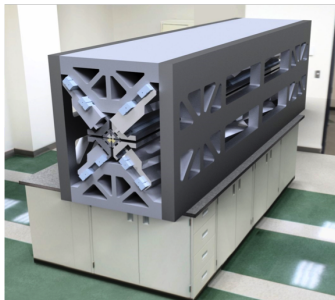


Figure by H.-D. Nuhn, SLAC, shown at ID2017 workshop at LBNL

## Arbitrary Polarizing SCU—SCAPE

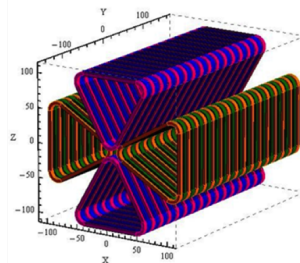
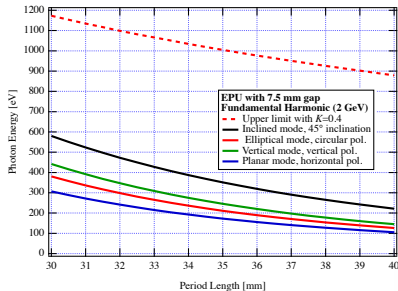
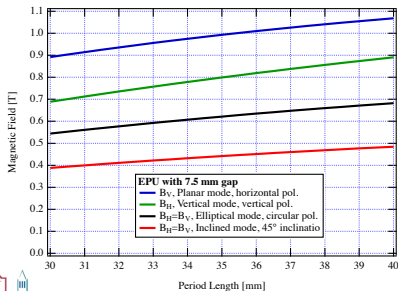
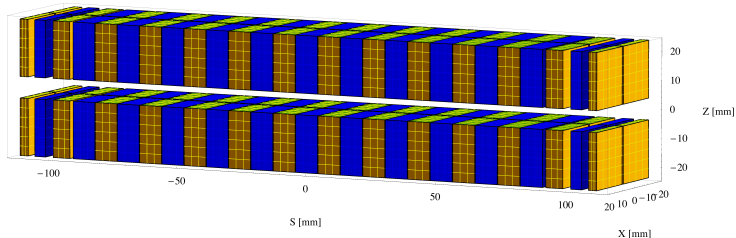
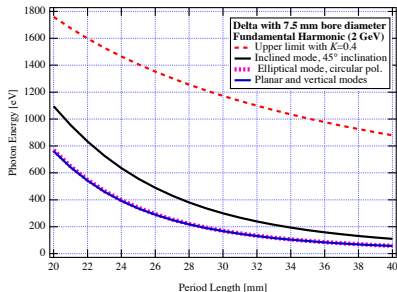
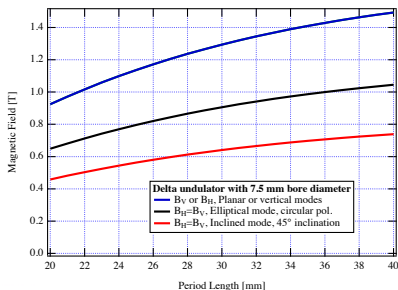
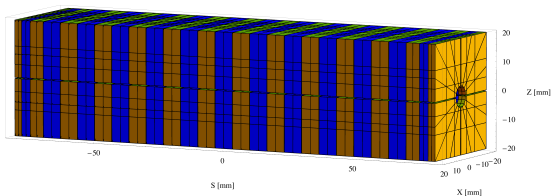


Figure by Y. Ivanyushenkov, APS, shown at ID2017 workshop at LBNL

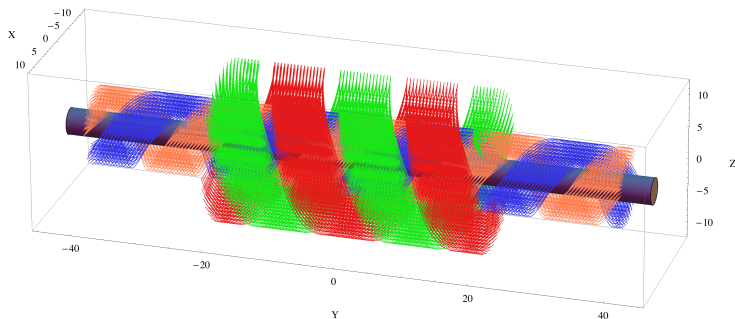
## Parameter studies of EPUs



## Parameter studies of Delta type undulators

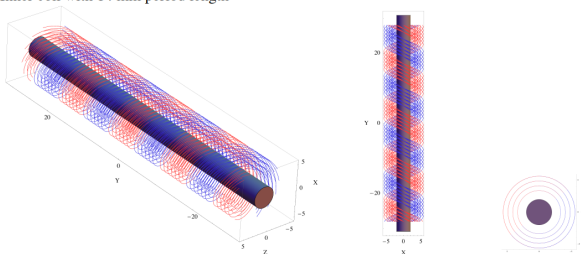


# Parameter studies of double helical superconducting undulators

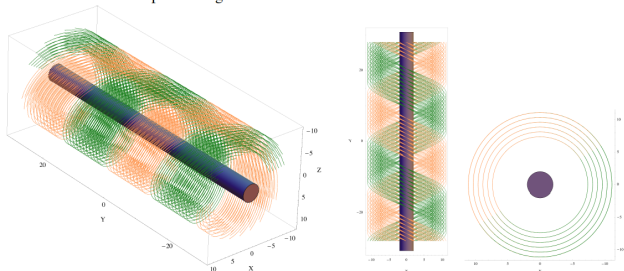


# Parameter studies of two period superconducting undulators

Inner coil with 14 mm period length



Outer coil with 28 mm period length



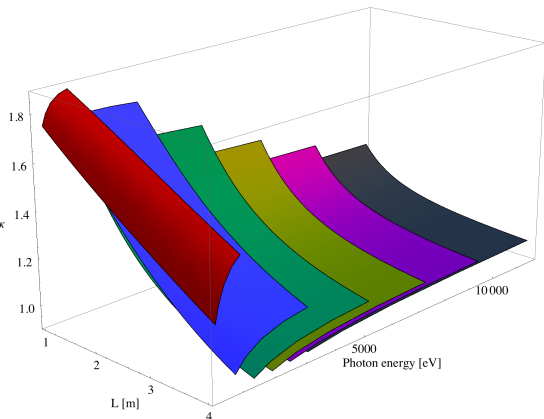


## The undulators are optimized to give the maximum brightness

Scaling of the brightness increase with increasing undulator length depends on the photon energy, undulator length, and harmonic, the beam parameters.

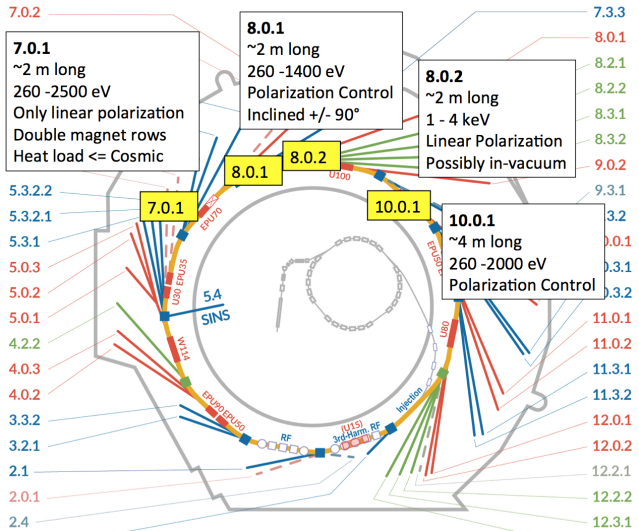
Horizontal Emittance	$\varepsilon_H$	64	pmrad	$\kappa$
Vertical Emittance	$\varepsilon_V$	64	pmrad	
Horizontal $\beta$ -function	$\beta_H$	3	m	
Vertical $\beta$ -function	$\beta_V$	3	m	
Beam Energy	$E$	2	GeV	
Energy Spread	$\sigma_\gamma$	8.13	$\times 10^{-4}$	
Undulator Period	$\lambda_0$	32	mm	
Undulator Strength	$K$	2		

$$\mathcal{B}_{nReal} \propto L^\kappa$$

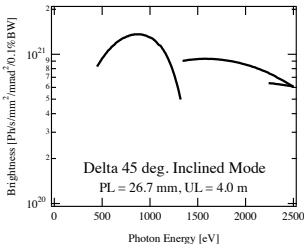
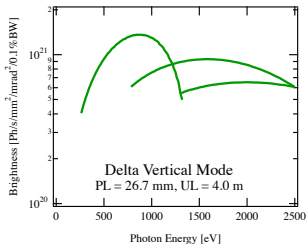
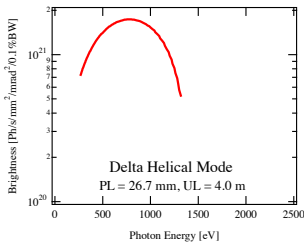
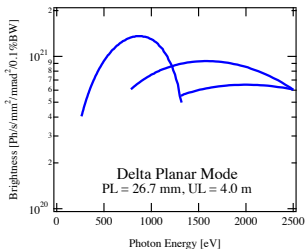


ALS-U Insertion Devices

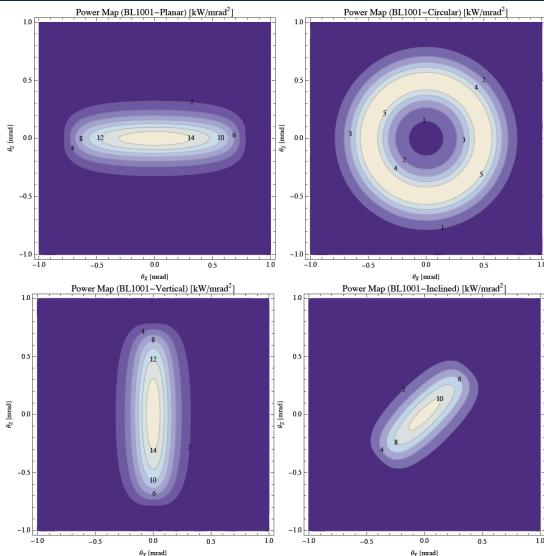
A selection process over the coming 6-9 months will determine the final undulator configuration of the ALS-U. A tentative selection of undulators is shown below.



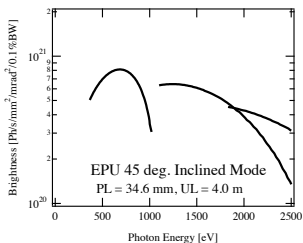
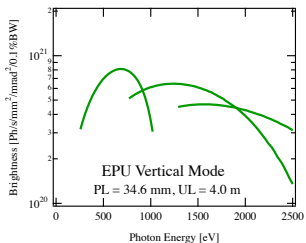
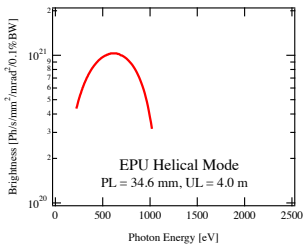
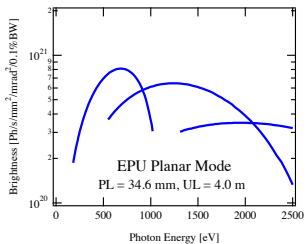
## Beamline 10.0.1 using a 4 m long Delta type undulator



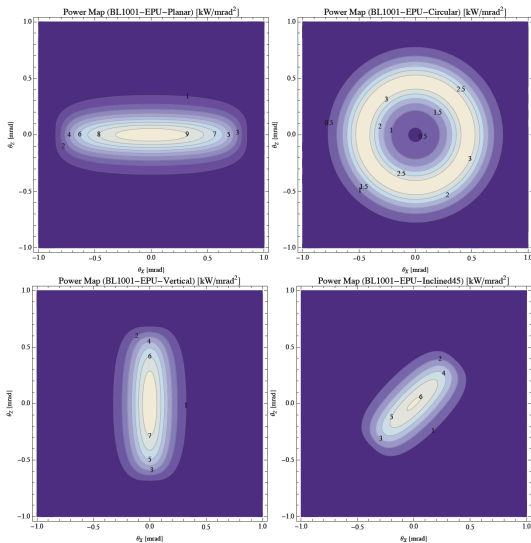
## Beamline 10.0.1 using a 4 m long Delta type undulator



## Beamline 10.0.1 using a 4 m long EPU



## Beamline 10.0.1 using a 4 m long EPU



## Insertion device challenges and prototyping

Vacuum system	Refurbishment of ALS IDs	Magnetic measurements	Robust designs	Prototyping
<p>The Delta or Type-X undulators requires 4.5 m long vacuum tubes with an inner diam of 4 mm.</p> <p>The vacuum level must be guaranteed by distributed pumping by NEG coatings.</p> <p>The long narrow vacuum tube will require adequate mechanical support for straightness and cooling to avoid overheating.</p> <p>Other parts of the vacuum system, such as front ends, may be exposed to high power densities of synchrotron radiation</p>	<p>The undulators that are reused from the existing ALS will operate at 0.5-1.7 mm smaller gaps and the heat load will be 23 % higher for the same photon energy.</p> <p>The mechanical systems of the undulators must stand 11% higher magnetic forces and be able to move to the smaller gap.</p> <p>The gap and phase motion control systems of the undulators must be updated for the future operation.</p>	<p>The reused undulators from the existing ALS shall be magnetically measured and if needed also tuned.</p> <p>For the large 4.5 m long undulators the magnetic measurements is best carried out in situ leaving the undulator in the ring.</p> <p>For standard undulators the UMF Hall probe bench can be used.</p> <p>For the in-situ magnetic measurements and for Delta type undulators a new closed bore meas. system is needed</p>	<p>The new undulators for ALS-U will be used over the coming 20 years.</p> <p>The undulators must stand frequent gap and phase changes over extended time periods.</p> <p>The undulators must stand the expected radiation levels without degraded performance.</p> <p>The chosen undulator technology should not dramatically increase the technical risk of the beamline or accelerator.</p>	<p>The main path for the prototyping will be to make prototype studies, possibly in collaboration with other labs, of the chosen Delta or X-type undulator.</p> <p>Prototyping of an alternative design using superconducting coils has great potential and shall be carried out if resources are available.</p> <p>A magnetic measurement system for closed bore geometries for Deltas, SCUs and in-situ meas. will be developed.</p>

## Summary

- ▶ The baseline lattice for the ALS-U is a 9 bend achromat with reversed bends from offset of the focusing quadrupoles in between the defocusing quad bender magnets.
- ▶ The natural emittance  $\varepsilon$  is 92 pmrad (without IBS)
- ▶ The fully couple H/V emittance  $\varepsilon_H / \varepsilon_V$  is 62 pmrad and the beta functions in center of the SS are  $\beta_H = 2.2\text{m}$  and  $\beta_V = 2.7\text{ m}$ .
- ▶ An accumulator ring and swap injection will be used. A prototype fast kicker magnet has been built and tested.
- ▶ It is challenging to accommodate all bend magnet and superbend beamlines when installing ALS-U
- ▶ Undulators with circular vacuum chamber can be used on ALS-U.
- ▶ The funding situation looks promising with a chance of receiving \$20M already fro FY 2018. The funding schedule would be the similar tor APS.

Thank you for your attention!





## Biannual Undulator Conference at the yearly SPIE August meeting in San Diego

SPIE is the international society for optics and photonics and the groups working with beamlines optics attend conferences arranged by SPIE.

**A biannual conference series on undulators will be arranged at the SPIE August meetings in San Diego starting year 2019.**

At the August 2019 meeting in San Diego there will also be a conference called "X-Ray Lasers and Coherent X-Ray Sources: Development and Applications".



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